

A Dynamic Approach to Monitoring Particle Fallout in a Cleanroom Environment



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- Particle fallout levels are commonly used for:
 - ± Estimating the effects of environmental exposure of sensitive surfaces
 - ± Development of contamination budgets
- Standard fallout measurement approaches require durations inversely proportional to the environmental cleanliness
- Cleanrooms are certified according to airborne particle count, and many cleanrooms are equipped with continuous monitoring
- The ability to estimate particle fallout based on airborne particle counts provides a more dynamic approach



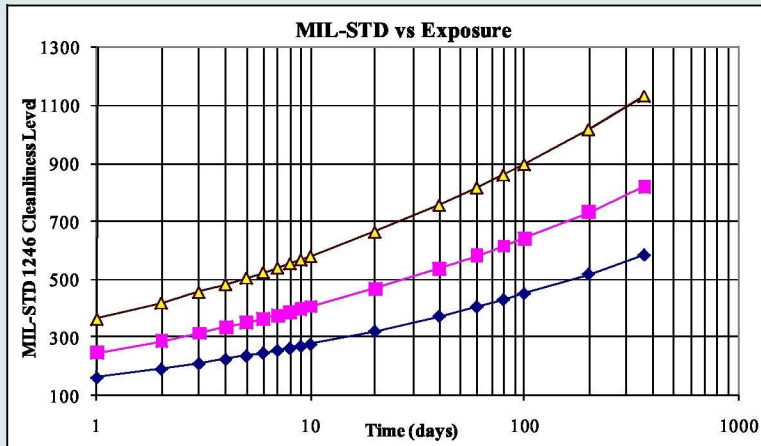
Assumptions



- Fallout rates are directly proportional to air quality
- Rates and quality directly reflect activity levels
- Once settled, particles remain
- Accumulation surfaces are horizontal

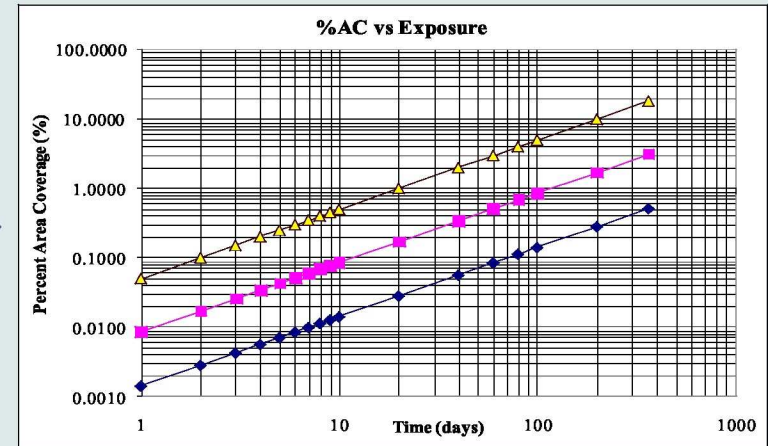
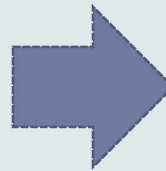


Simple Approach



Adapted from Hamburg, Proc. IES (1982)

- Previous studies correlated cleanliness class to cleanliness level
 - Cleanliness level is sensitive to particle distributions
 - ✦ MIL-STD 1246 (IEST-STD-CC-1246) cleanliness levels use -0.926 distribution slope
 - ✦ Airborne particle distribution follows a -0.28 slope
 - ✦ Distribution of particle fallout is -0.383
 - Results in non-linear relationship



- Correlation to a normalized area coverage (e.g. PAC) provides a linear time relationship
- Simple substitution remains non-linear for cleanroom class



- Airborne Particle Distribution (FED-STD-209)

$$n_x = Class * \left(\frac{0.5}{x} \right)^{2.2}$$

- Effective Column Height (Stokes Coefficient)

$$\nu = \frac{2 * g * r^2 * (d_1 - d_2)}{9\mu}$$

Caveat: Limit column height by ceiling height and air exchanges

- Obscuration Factor

$$OF = \left(\frac{x}{AR} \right)^2 * \left(\frac{\pi}{4} + AR - 1 \right)$$

Particle Size (microns)	Aspect Ratio (L:W)
1 - 69	X ^{0.1088}
70 - 175	X ^{0.8804} /26.53
176 - 346	X ^{2.589} /181500
> 346	X ^{0.8964} /9.138

Adapted from Ma, Fong, and Lee, SPIE 1165 (1989)



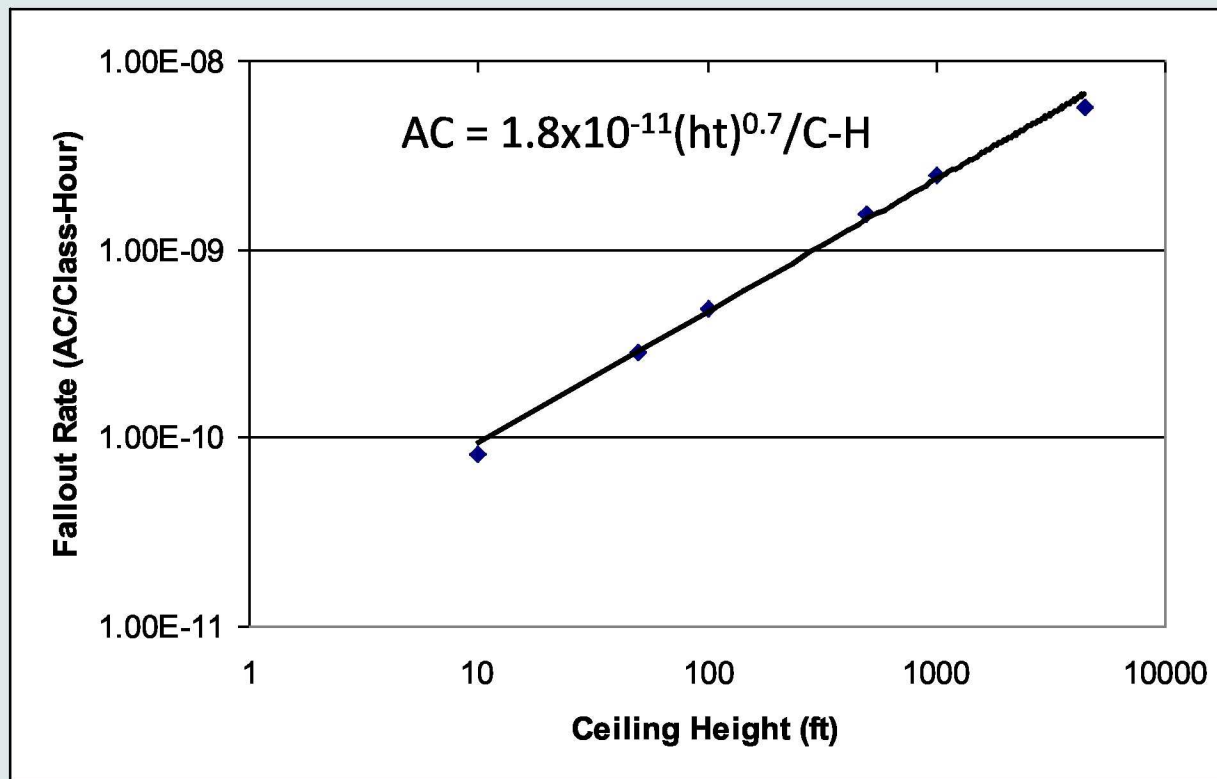
- Combination of distribution, column height, and obscuration factor provides a linear correlation of area coverage (AC) to cleanroom class and time (Class-Hours)

$$AC_x = \left[\frac{n_{x+1} - n_x}{Class} \right] * \left[V_{OF} * \frac{3600s}{hr} * \frac{ft}{30.48cm} \right] * \left[OF * \frac{1.076 \times 10^{-11} ft^2}{\mu m^2} \right]$$

- A spreadsheet was used to determine the incremental contribution of AC for particles in 1 micron bins from 1 to 1000 microns



Numerical Results



For ISO 14644-1: $n_x = 10^{Class} * \left(\frac{0.1}{x} \right)^{2.08}$ therefore $AC = 4.7 \times 10^{-14} (ht)^{0.81} / C-H$



□ Predictive:

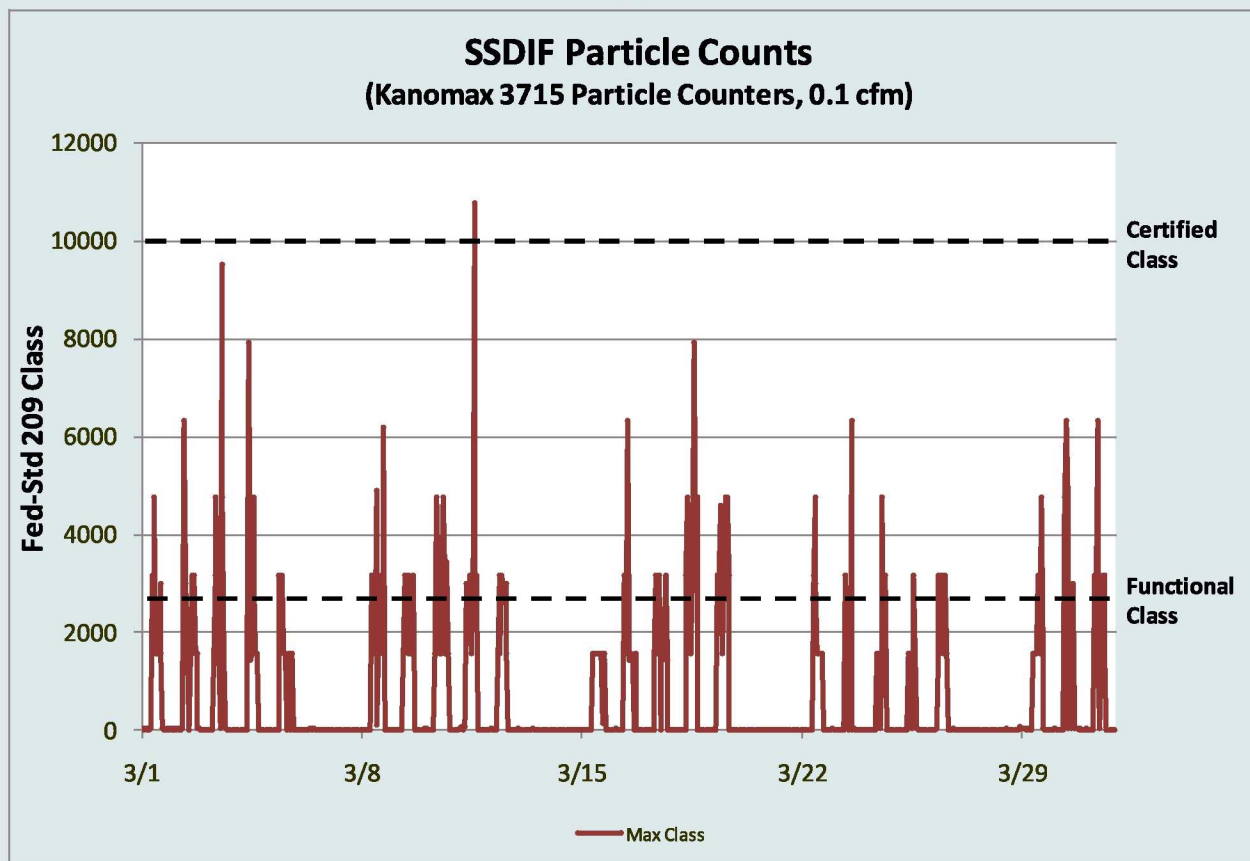
- ± Assume a limit of 0.1 PAC in a facility with a 100 foot ceiling, this results in 2.2×10^6 Class-Hours
 - For a Class 10K facility: 220 hours
 - For one month duration: Class 3000
- ± Assume covering off-shift (2/3 of each day)
 - For a Class 10K facility: 660 hours
 - For one month duration: Class 9000

□ Dynamic:

- ± Cleanroom environments are rarely static, but vary with activity level
- ± Airborne particle counters can provide real-time data

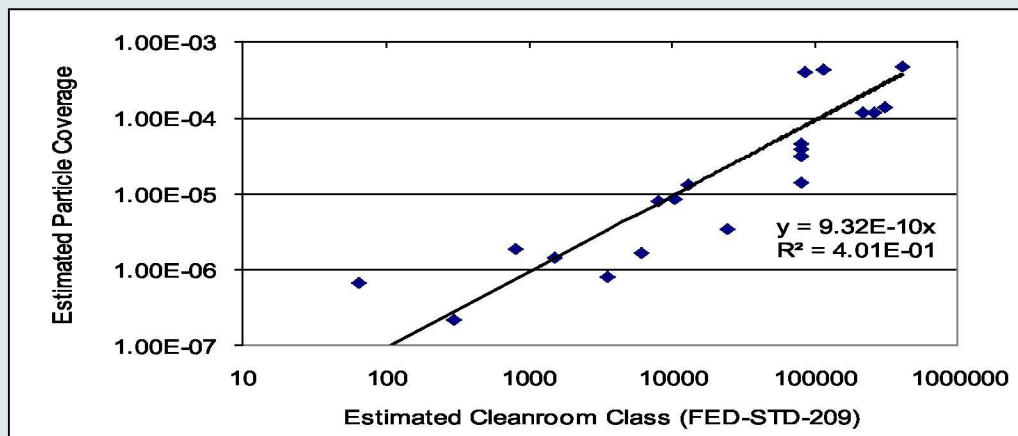


Application



- Hourly monitoring sums to 5.15×10^5 Class-Hours (>75% margin)

- Ongoing monitoring at GSFC SSDIF
 - Estimated AC/C-H (100 ft ceiling): 4.5×10^{-10}
 - {Estimated AC/C-H (43 exchanges/hr): 5.9×10^{-9} }
 - Measured AC/C-H ($5 \mu\text{m}$ channel): $4.9(\pm 8.0) \times 10^{-10}$
 - {Measured AC/C-H ($0.5 \mu\text{m}$ channel): $4.6(\pm 9.2) \times 10^{-9}$ }
- Hamburg data: 9.3×10^{-10} AC/C-H



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